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PATENT
03345-P0047A WWW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Markus Schwambera, et al.
Serial No. 10/754,817	Filing Date: January 9, 2004
Title of Application:	Process Chamber with a Base with Sectionally Different Rotational Drive and Layer Deposition Method in Such a Process Chamber
Confirmation No. 1549	Art Unit: 1762
Examiner	

Mail Stop Amendment
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Election Pursuant to Restriction Requirement

This is a response to the Examiner's telephone conference on August 18, 2004 with Wesley W. Whitmyer, Jr. re an Election.

Applicants hereby elect the invention of apparatus Claims 2, 11-18 for prosecution in this case. Claims 1 and 3-6 are reserved for filing in a future application.

Respectfully submitted,

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Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

September 1, 2004

Beatrice R. Emerson